Docket No.

255449US0PCT

IN RE APPLICATION OF: Takeshi KUMAGAI, et al.

SERIAL NO: 10/500,150 FILED:

July 12, 2004

FOR:

CVD METHOD AND DEVICE FOR FORMING SILICON-CONTAINING INSULATION FILM

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

Transmitted herewith is an amendment in the above-identified application.

- No additional fee is required
- ☐ Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.
- ☐ Additional documents filed herewith:

The Fee has been calculated as shown below:

| CLAIMS | CLAIMS REMAINING | | HIGHEST NUMBER PREVIOUSLY PAID | NO. EXTRA CLAIMS | | RATE | | CALCULATIONS |
|------------------|---------------------|---|---|---------------------------------|---|-------|--------|--------------|
| TOTAL | 20 | MINUS | 20 | 0 | х | \$50 | = | \$0.00 |
| INDEPENDENT | 3 | MINUS | 3 | 0 | х | \$200 | = | \$0.00 |
| APPLICATION SIZE | | MINUS | 100 | 0 (each addtl. 50 sheets) | x | \$250 | = | \$0.00 |
| | | ☐ MULTIPLE DEPENDENT CLAIMS + \$360 = | | | | | | \$0.00 |
| | | TOTAL OF ABOVE CALCULATIONS | | | | | | \$0.00 |
| | | ☐ Reduction by 50% for filing by Small Entity | | | | | | \$0.00 |
| TOTAL | | | | | | AL | \$0.00 | |

| ☐ A check in the amount of \$0.00 is attached | | A check in | the amount | of \$0.00 is | s attached |
|---|--|------------|------------|--------------|------------|
|---|--|------------|------------|--------------|------------|

- ☐ Credit card payment form is attached to cover the fees in the amount of \$0.00
- Please charge any additional Fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.
- If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, P.C.

Norman F. Oblon

Registration No. 49

Customer Number

22850

Tel. (703) 413-3000 Fax. (703) 413-2220 (OSMMN 05/03)

DOCKET NO: 255449US0PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

RE APPLICATION OF

TAKESHI KUMAGAI, ET AL. : EXAMINER: LE, THAO P.

SERIAL NO: 10/500,150

FILED: JULY 12, 2004 : GROUP ART UNIT: 2818

FOR: CVD METHOD AND DEVICE FOR

FORMING SILICON-CONTAINING

INSULATION FILM

AMENDMENT

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated January 31, 2006, Applicant requests reconsideration of the above-identified application in view of the following amendments and remarks:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Support for the Amendment begins on page 5 of this paper.

Remarks/Arguments begin on page 6 of this paper.